

Inventor: Shozo Nagano et al.  
Title: Physical Vapor Deposition Target  
Assignee: Honeywell International Inc.

**INFORMATION DISCLOSURE STATEMENT**

#18

References – See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether any of the submitted references is prior art. Copies of the references are attached.

**RECEIVED**

Respectfully submitted,

MAR 05 2003

**GROUP 1700**

Dated:

2-26-2003

Attorney:

Jennifer J. Taylor  
Jennifer J. Taylor, Ph.D.  
Reg. No. 48,711